



Japan PV Committee Japan PV Materials Committee Meeting Summary and Minutes

Japan Standards Spring 2014 Meetings Friday, March 7, 2014, 3:30 p.m. – 4:50 p.m. Conference Room 1,SEMI Japan, Tokyo

Next Committee Meeting

Friday, July 4, 2014, 1:30 p.m. – 5:00 p.m. < Japan Standard Time> Japan Summer 2014 Meetings, Tokyo, Japan

Committee Announcements (optional)

None

Table 1 Meeting Attendees

Co-Chairs: Masaaki Yamamichi (AIST), Hiromu Takatsuka (Mitsubishi Heavy Industries), Kazuhiko Kashima

(GlobalWafers Japan), Terry Asakawa (Tokyo Electron)

SEMI Staff: Chie Yanagisawa

Attendee: 5 + SEMI: 1

Company	Last	First	Company	Last	First
AIST	Yamamichi	Masaaki	Mitsubishi Electric	Ishihara	Takashi
AIST	Fukuda	Tetsuo	Sumika Chemical Analysis Service	Watanabe	Satoru
Fuji Film	Miyake	Kiyoteru			

^{*} alphabetical order by company name

Japan PV Committee

Table 2 Leadership Changes

Group	Previous Leader	New Leader
Japan Chapter of PV TC		Kazuhiko Kashima (GlobalWafers Japan), Masaaki Yamamichi (AIST) and Hiromu Takatsuka (Mitsubishi Heavy Industries) remained.

Table 3 Ballot Results (or move to Section 4, Ballot Review)

None

Table 4 Authorized Ballots (or move to Section 7, New Business)

None

Table 5 Authorized Activities (or move to Section 7, New Business)

None

Table 6 New Action Items (or move to Section 8, Action Item Review)

None

Table 7 Previous Meeting Actions Items (or move to Section 8, Action item Review)

None





Japan PV Materials Committee

Table 8 Leadership Changes

None

Table 9 Ballot Results (or move to Section 4, Ballot Review)

None

Table 10 Authorized Ballots (or move to Section 7, New Business)

#	When	SC/TF/WG	Details
5532	- 3		New Standard: Test Method for Measurement of Cracks in PV Silicon Wafers in PV Modules by Laser Scanning

Table 11 Authorized Activities (or move to Section 7, New Business)

None

Table 12 New Action Items (or move to Section 8, Action Item Review)

None

Table 13 Previous Meeting Actions Items (or move to Section 8, Action item Review)

None

1 Welcome, Reminders, and Introductions

Masaaki Yamamichi called the meeting to order at 3:30 p.m. The meeting reminders on antitrust issues, intellectual property issues and holding meetings with international attendance were reviewed. Attendees introduced themselves.

2 Review of Previous Meeting Minutes

The committee reviewed the minutes of the previous meeting.

Motion:	To approve as written.
By / 2 nd :	Tetsuo Fukuda (AIST) / Takashi Ishihara (Mitsubishi Electric)
Discussion:	None
Vote:	4-0 Motion passed.

3 Liaison Reports

3.1 China PV Committee

Chie Yanagisawa (SEMI Japan) reported for the China PV Committee as attached.

Attachment: 01_China Photovoltaic Committee Liaison Report20131125

3.2 Europe PV Materials Committee

Chie Yanagisawa reported for the Europe PV Materials Committee as attached.

Attachment: 02_EU PV Materials Liaison Report 20131022

3.3 North America PV Materials Committee

Chie Yanagisawa reported for the North America PV Materials Committee as attached.

Attachment: 03_NA Liaison Report PV Materials 20131112





3.4 Taiwan PV Committee

Chie Yanagisawa reported for the Taiwan PV Committee as attached.

Attachment: 04_Taiwan Liaison Report for SJ Meeting December 2013_PV

3.5 SEMI Staff Report

Chie Yanagisawa gave the SEMI Staff Report. Of note:

- Global SEMI Events
- · Global Standards Meetings Schedule
- Ballot Critical Dates
- Publication Update
- Contact Information

Attachment: 05_SEMI Staff Report 2014 Mar._R0.3a

4 Ballot Review

None

5 Task Force Reports

5.1 Japan PV Materials Task Force

Tetsuo Fukuda reported for the Japan PV Materials Task Force Task Force. This report contained information on the draft of Ballot #5532 "New Standard: Test Method for Measurement of Cracks in PV Silicon Wafers in PV Modules by Laser Scanning". The proposal of the ballot submission to Cycle 3 would be made at the new business section later at this meeting.

6 Old Business

6.1 Step down of Terry Asakawa

Chie Yanagisawa reported the committee that Terry Asakawa (Tokyo Electron) stepped down from the co-chair of the Japan Chapter of PV TC.

7 New Business

7.1 Proposal of Ballot Submission of Doc. #5532

Tetsuo Fukuda addressed the committee on this topic and the motion was made as follows.

:	To submit Ballot #5532 "New Standard: Test Method for Measurement of Cracks in PV Silicon Wafers in PV Modules by Laser Scanning" for Cycle 3-2014
	Tetsuo Fukuda (AIST) / Takashi Ishihara (Mitsubishi Electric)
Discussion:	None
Vote:	4-0 Motion passed.

8 Action Item Review

8.1 Open Action Items

None

8.2 New Action Items

None





9 Next Meeting and Adjournment

The next joint meeting of the Japan Chapters of PV TC and PV Materials TC is scheduled for Friday, July 4, 2014 at Standards Summer 2014 Meetings in Tokyo.

Having no further business, a motion was made by Masaaki Yamamichi, co-chair, to adjourn the joint meeting of Japan Chapters of PV TC and PV Materials TC at Conference Room 2, SEMI Japan. The meeting unanimously adjourned at 4:50 p.m.

Respectfully submitted by:

Chie Yanagisawa

Senior Standard Coordinator

SEMI Japan

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Minutes approved by:

Masaaki Yamamichi (AIST), Co-chair	July 4, 2014
Tetsuo Fukuda (AIST), Co-chair	July 4, 2014
Takashi Ishihara (Mitsubishi Electric), Co-chair	July 4, 2014

Table 14 Index of Available Attachments #1

#	Title	#	Title
01	China Photovoltaic Committee Liaison Report20131125		Taiwan Liaison Report for SJ Meeting December 2013_PV
02	EU PV Materials Liaison Report 20131022	05	SEMI Staff Report 2014 MarR0.3a
03	NA Liaison Report PV Materials 20131112		

^{#1} Due to file size and delivery issues, attachments must be downloaded separately. A .zip file containing all attachments for these minutes is available at www.semi.org. For additional information or to obtain individual attachments, please contact [SEMI Staff Name] at the contact information above.